



Extended cut-off wavelength nBn detector utilizing InAsSb/InSb digital alloy

Alexander Soibel, David Z. Ting, Cory J. Hill, Anita M. Fisher, Linda Hoglund, Sam. A. Keo, and Sarath D. Gunapala

*Infrared Photonics Group
Jet Propulsion Laboratory
California Institute of Technology*



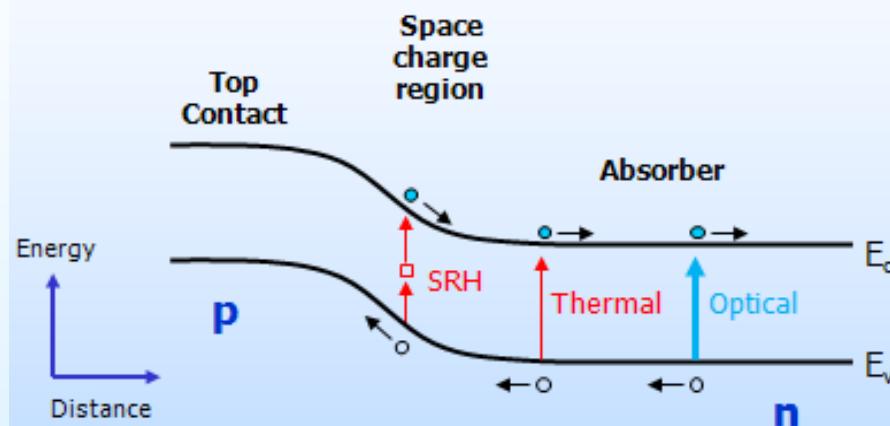
Outline



- Barrier Infrared Detector (BIRD)
 - **InAsSb nBn detector**
 - Quantum Dot Barrier Infrared detector
 - Digital alloy InAsSb/InSb Barrier Infrared detector

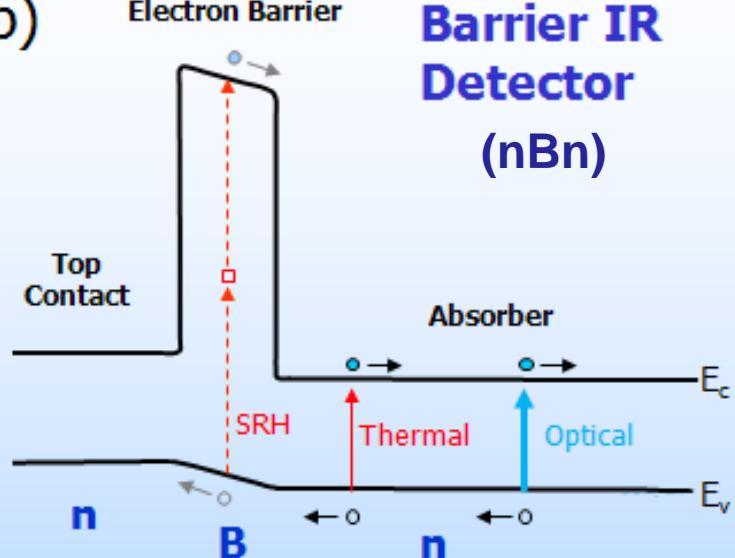
Barrier Infrared detectors

(a) p-n diode



(b)

Electron Barrier



Barrier IR
Detector
(nBn)

Barrier Infrared Detectors (BIRD)

- Different implementations: nBn, XBn, pBn, CBIRD, ...
- Utilizes unipolar barriers
- Block one carrier type, but allows un-impeded flow of the other

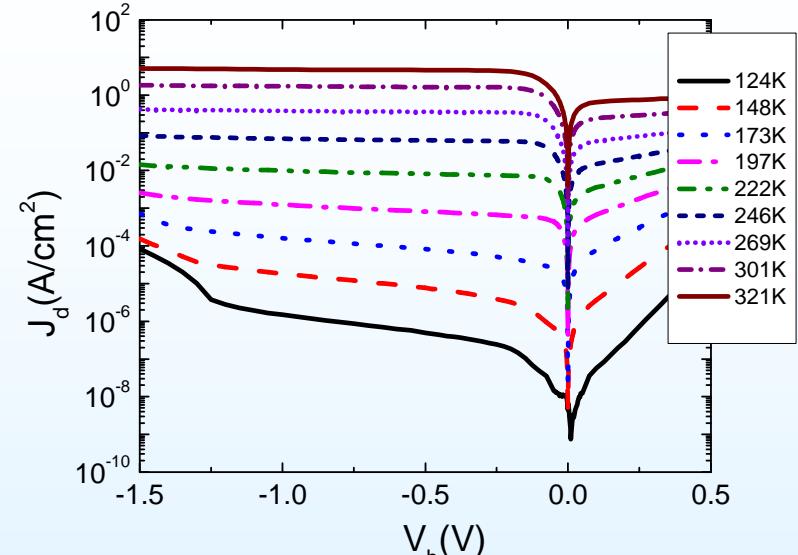
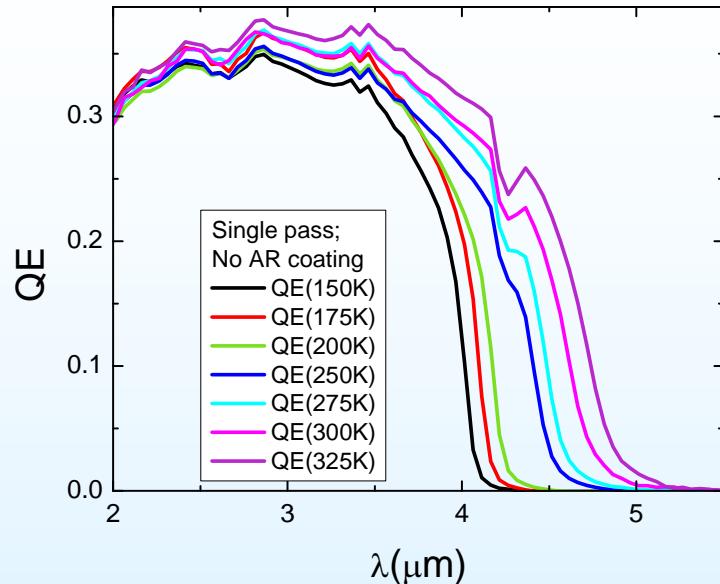
BIRD advantages

- Suppressed generation-recombination current
- Simplified fabrication process utilizing shallow etching into the barrier
- Elimination of surface leakage currents

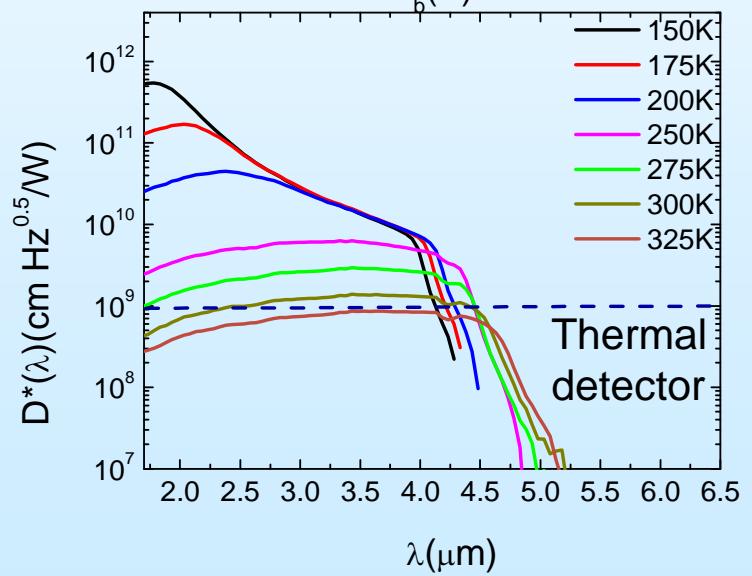
nBn utilizing an InAsSb/AlAsSb absorber-barrier combination

- Cut-off wavelengths in this design is limited to about $\lambda_c = 4 \mu\text{m}$

Maimon, S., and G. W. Wicks (2006). nBn detector, an infrared detector with reduced dark current and higher operating temperature. *Appl. Phys. Lett.* 89, 151109
Klipstein, P. (2008). 'XBn' barrier photodetectors for high sensitivity and high operating temperature infrared sensors. *Proc. SPIE* 6940, 6940U-2.



- Very good performance up to high temperatures
 - High QE
 - $\lambda_c = 3.8\mu\text{m}$ at $T = 77\text{K}$
 - $\lambda_c = 4.7\mu\text{m}$ at $T = 325\text{K}$
 - Low dark current
 - $j_d = 7 \times 10^{-7} \text{ A/cm}^2$ at $T = 148\text{K}$
 - $j_d = 6 \times 10^{-2} \text{ A/cm}^2$ at $T = 246\text{K}$
 - High Detectivity
 - BLIP below 225K
 - $D^*(\lambda) = 5 \times 10^9 (\text{cm Hz}^{0.5}/\text{W})$ at 250K



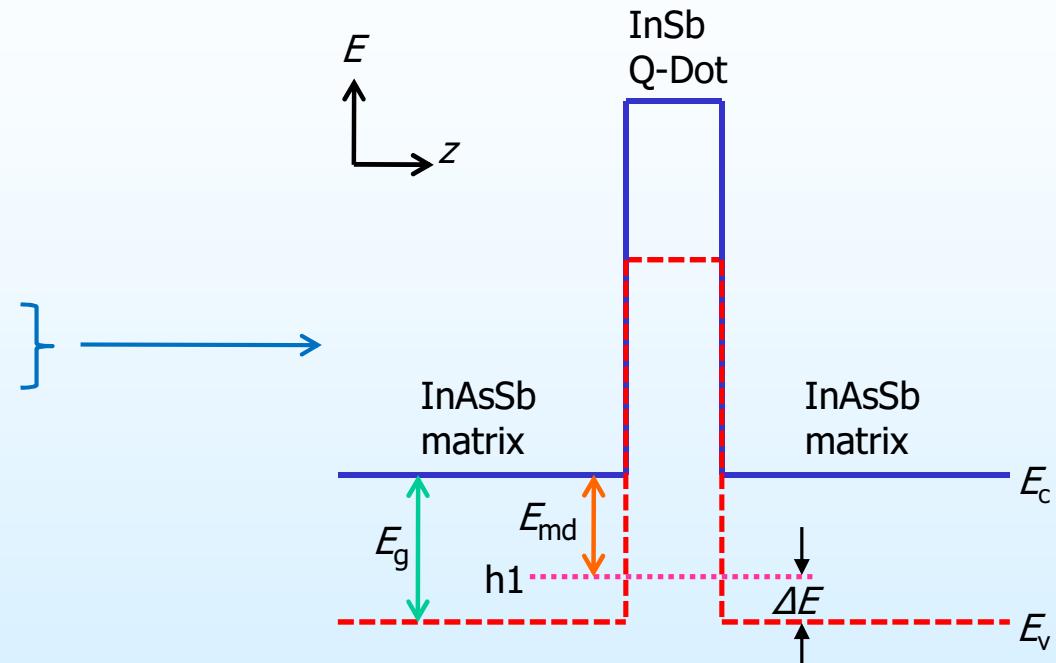
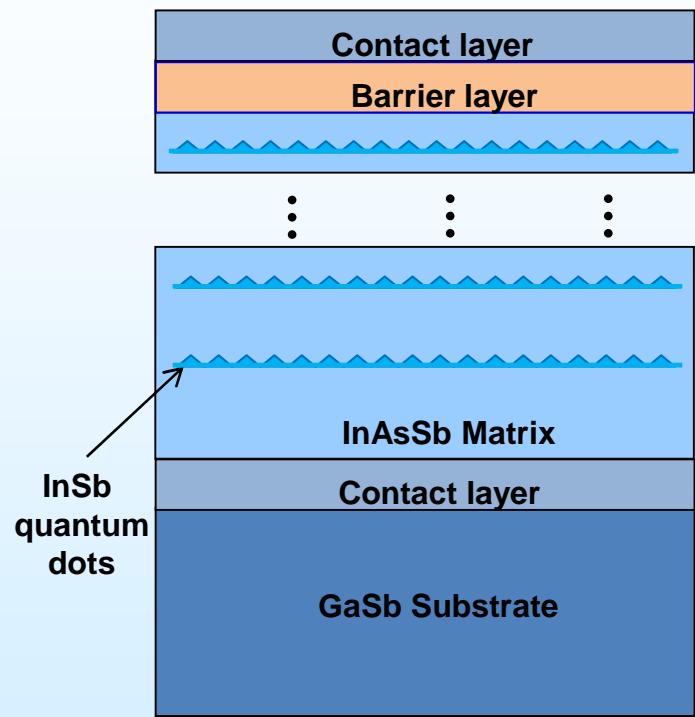


Outline



- Barrier Infrared Detector (BIRD)
 - InAsSb nBn detectors
 - **Quantum Dot Barrier Infrared detector**
 - Digital alloy InAsSb/InSb Barrier Infrared detector

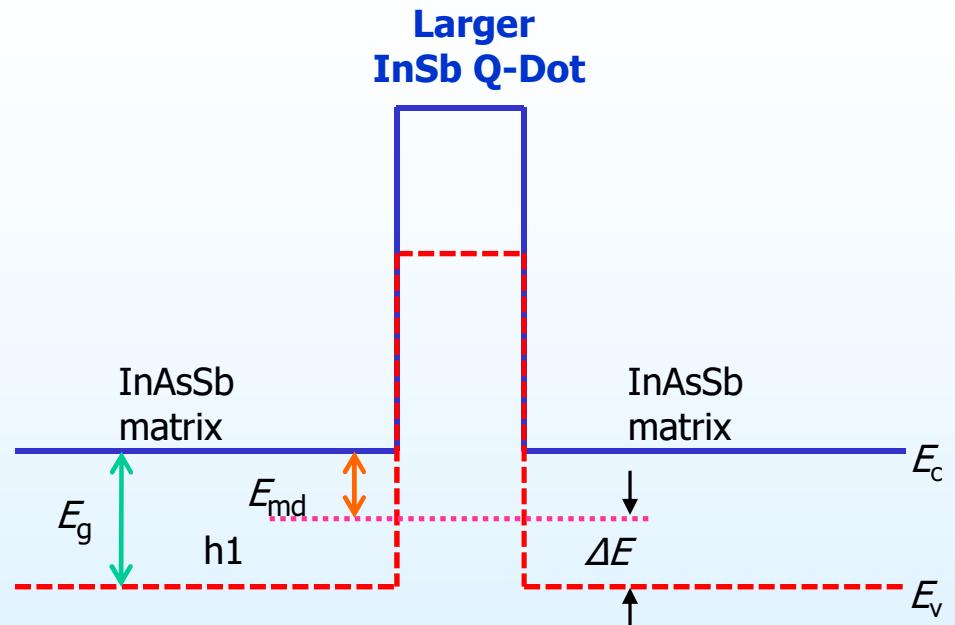
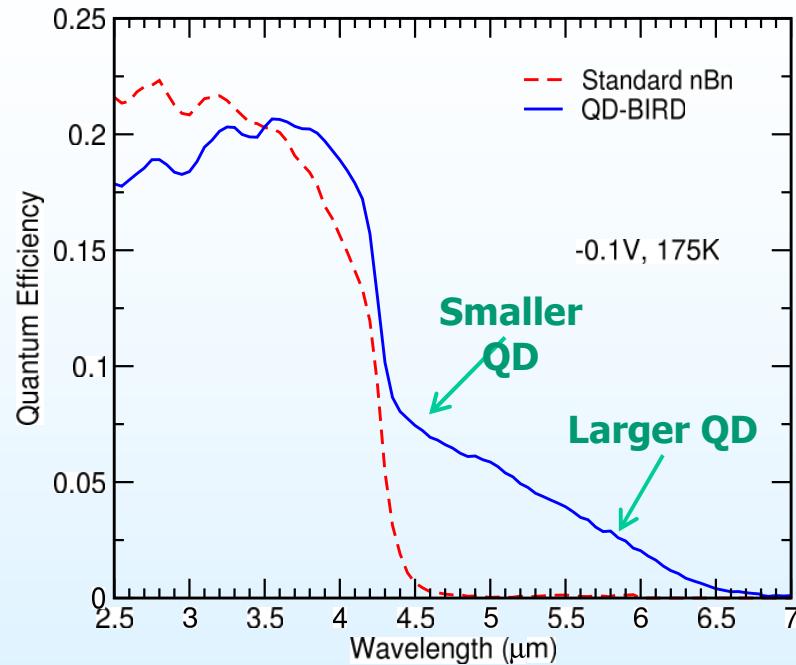
How to extend cut-off wavelength of InAsSb BIRD detector?



- Quantum Dot (QD) BIRD is based on a simple modification of the standard nBn
- Periodic insertion of InSb quantum dot layers

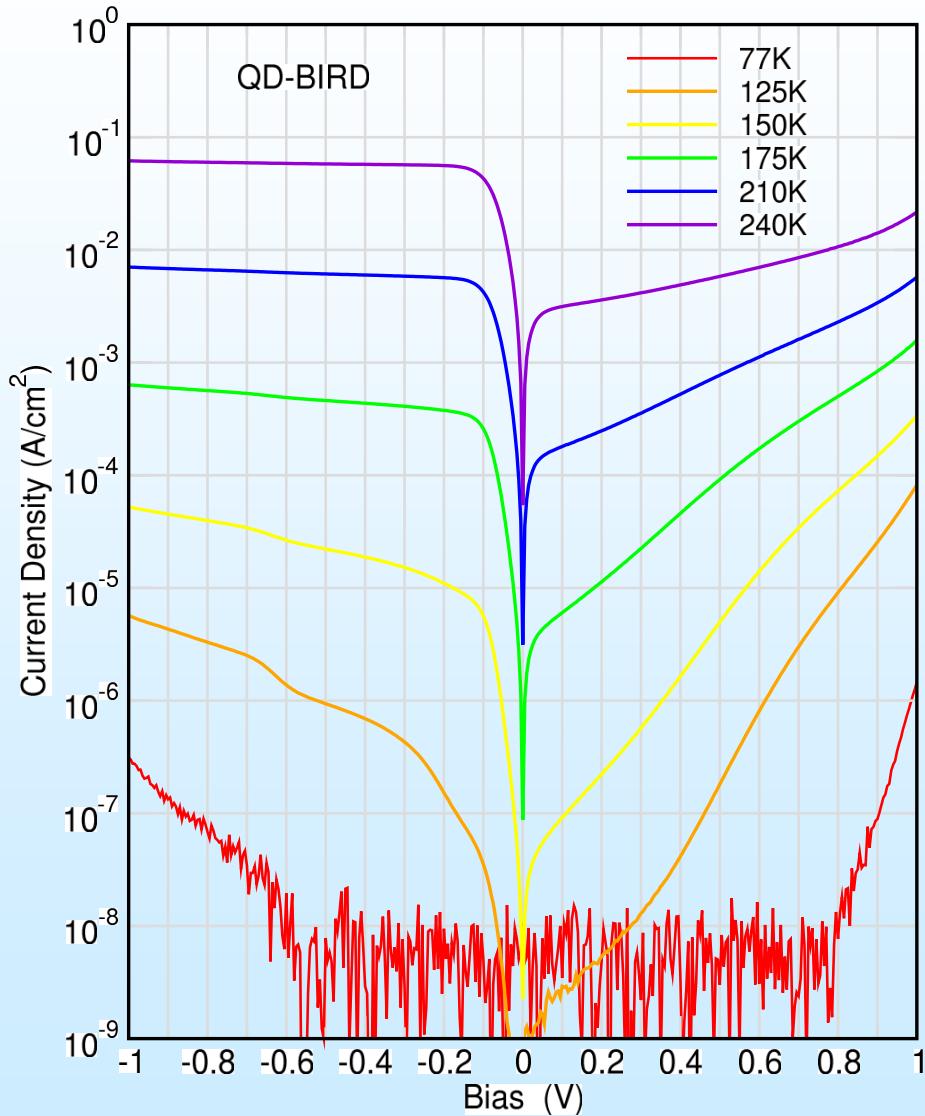
- Type-II broken-gap band alignment between InSb and InAsSb
- InSb QD conduction band state is in the continuum (unconfined)
- InSb QD valence band state can be confined in the gap of InAsSb matrix

Photo-Response and Dot Size Distribution



- Bimodal behavior found for spectral response as in PL spectrum
- Extended response out to $\sim 6\mu\text{m}$
 - Weaker than InAsSb bulk response
 - QE decreases with wavelength
Attributed to Quantum Dot size distribution
 - Large QDs have
 - Smaller transition energy E_{md} , longer absorption wavelength
 - Larger activation energy ΔE , lower hole escape probability, reduced photo-response

Dark Current Density and D*



- Higher temperature reverse-bias I-V appears diffusion limited
- Lower temperature I-V shows exponential increase
 - Fowler-Nordheim barrier
- Reasonably low dark current
 - $J(-0.2V, 175K) = 3.77 \times 10^{-4} \text{ A/cm}^2$
 - $J(-0.2V, 125K) = 1.52 \times 10^{-7} \text{ A/cm}^2$
- Black-body D*
 - f/2, 300K background
 - Use integrated photo-response from 3 μm to 6 μm
 - $D^*(-0.2V, 175K) = 1.07 \times 10^{11} \text{ cm-Hz}^{1/2}/W$
 - Dark current limited
 - $D^*(-0.2V, 125K) = 3.76 \times 10^{12} \text{ cm-Hz}^{1/2}/W$
 - Background limited

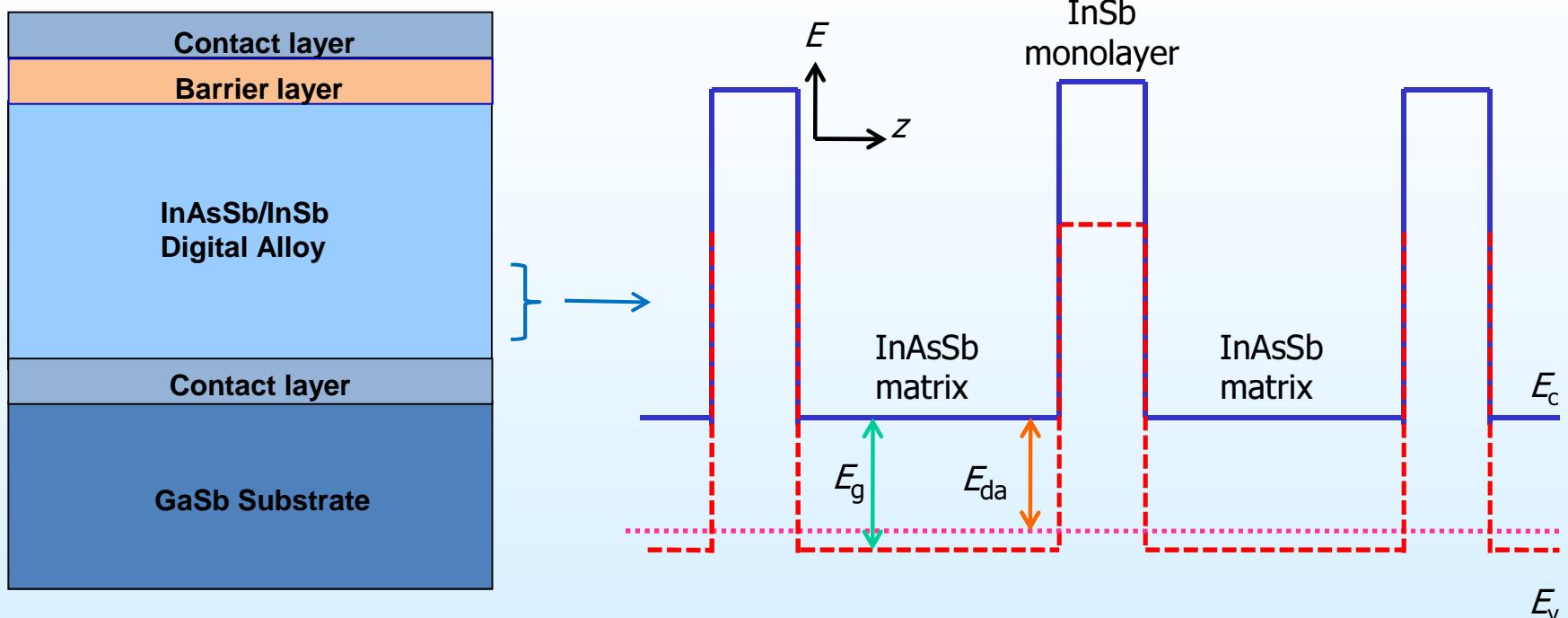


Outline



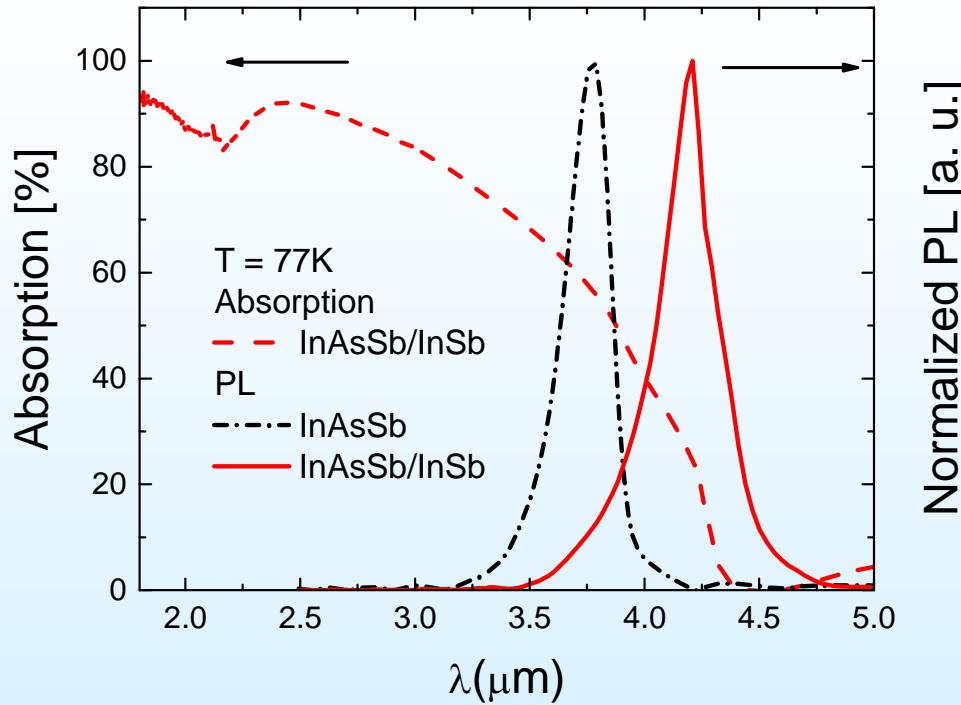
- Barrier Infrared Detector (BIRD)
 - InAsSb nBn detectors
 - Quantum Dot Barrier Infrared detector
 - **Digital alloy InAsSb/InSb Barrier Infrared detector**

How to extend cut-off wavelength of InAsSb BIRD detectors?



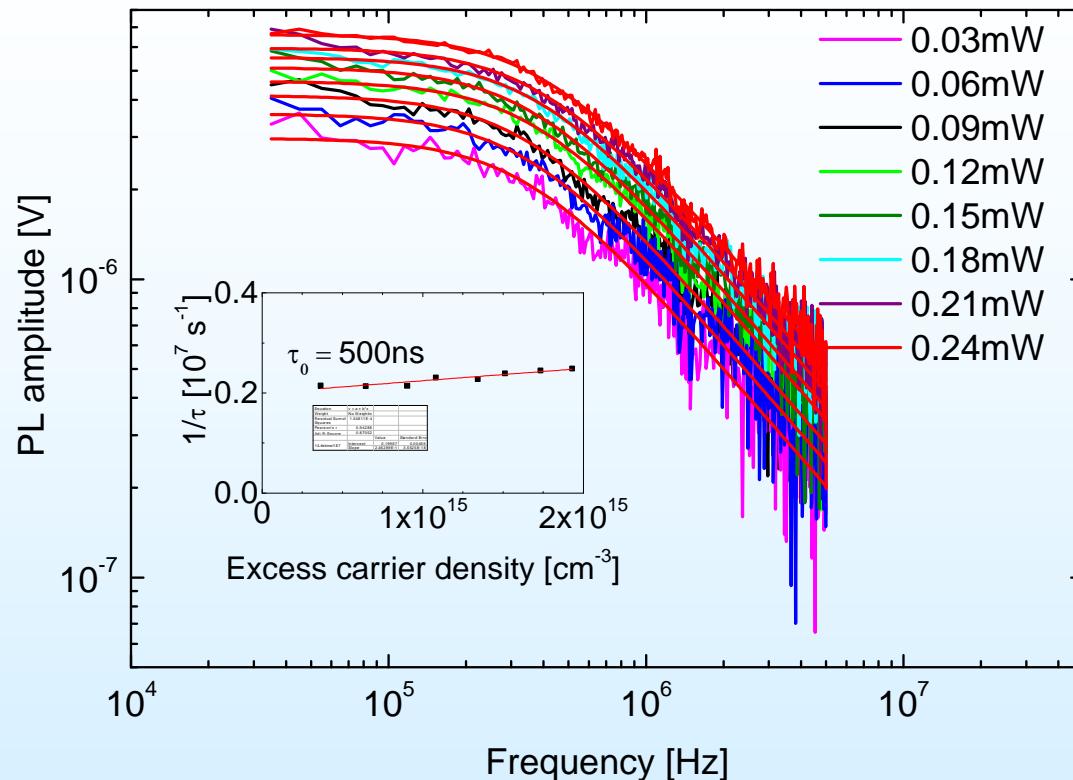
- Digital alloy InAsSb/InSb is based on a simple modification of the standard nBn
- Periodic insertion of InSb monolayers
 - A single InSb monolayer after every 14 monolayers of $\text{InAs}_{0.92}\text{Sb}_{0.08}$
- Type-II broken-gap band alignment between InSb and InAsSb
- New level with transition energy, E_{da}
 - Transition energy $E_{da} < E_g$, where E_g is InAsSb bandgap

PL and absorption



- At $T = 77\text{K}$, the digital alloy exhibits PL peak = $4.21\mu\text{m}$
 - Compared to the = $3.79\mu\text{m}$ of $\text{InAs}_{0.915}\text{Sb}_{0.085}$ bulk material
 - Compared to the = $5.5\mu\text{m}$ of InSb QD embedded in $\text{InAs}_{0.915}\text{Sb}_{0.085}$ bulk material
- The absorption spectrum of the $2\mu\text{m}$ thick digital alloy absorber is shown above
 - Absorption is $a = 70\%$ and the absorption coefficient is $a_c = 2900 \text{ cm}^{-1}$ at $\lambda = 3.4 \mu\text{m}$
- The transmission of the GaSb substrate used for the growth of these devices was found to be higher than $>95\%$ for $\lambda < 6\mu\text{m}$

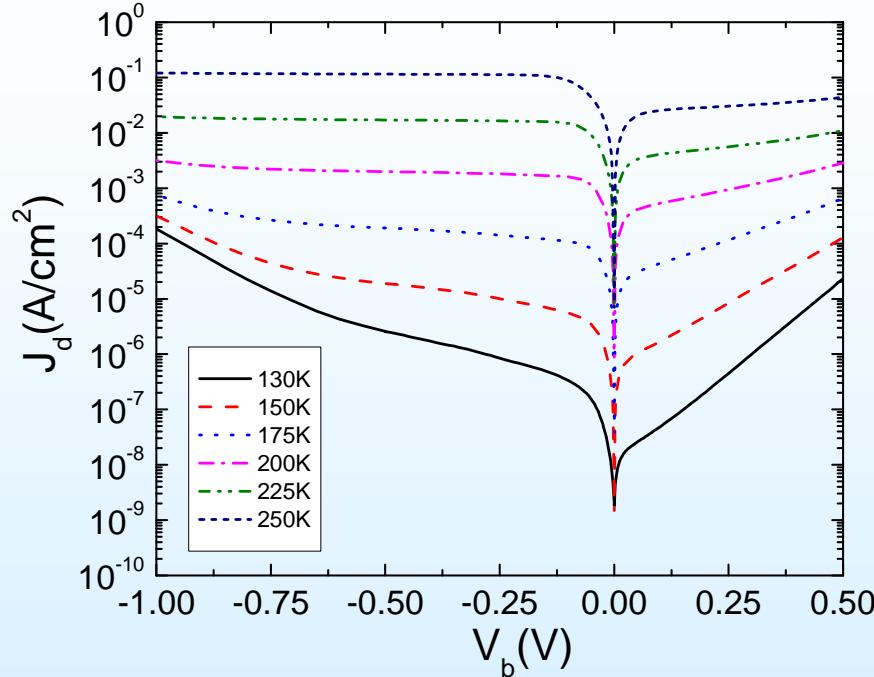
Lifetime



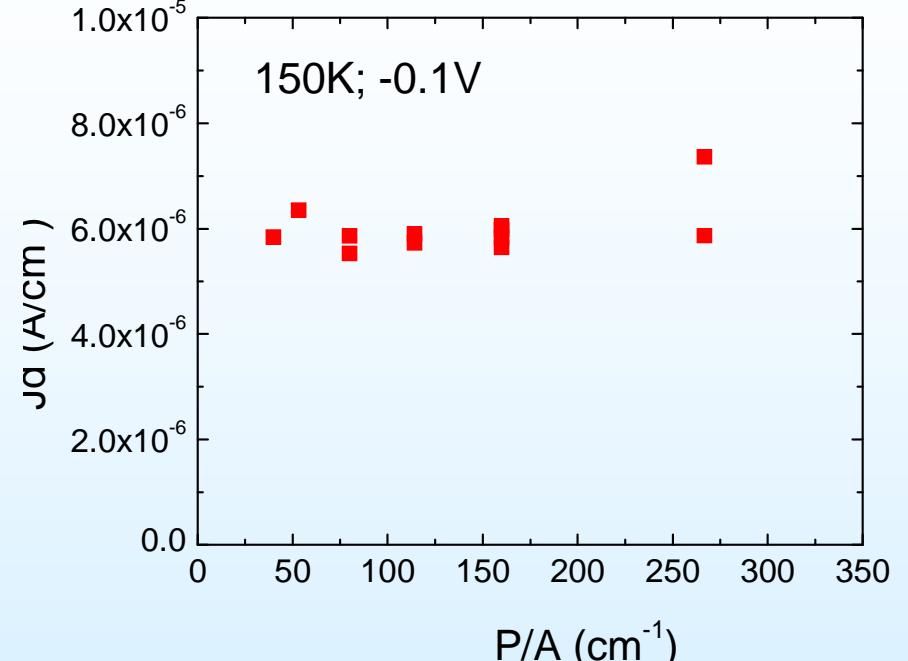
- The minority carrier lifetime in the digital alloy, $\tau_{da} = 500$ ns, at $T = 77$ K
- The estimated radiative recombination time $\tau_r = 470\text{-}570$ ns
 - From the absorption spectrum and the carrier concentration, $n_{abs} = 3\text{-}4 \times 10^{14}$ cm $^{-3}$
 - Close to the experimentally measured lifetime
 - Radiative recombination controls the minority carrier lifetime at $T = 77$ K
- The minority carrier lifetime in InAs_{0.915}Sb_{0.085} bulk material $\tau_{bulk} = 300$ ns
 - For carrier concentration of $n = 1\text{-}2 \times 10^{15}$ cm $^{-3}$

Dark current

Dark current density vs. applied bias at different T

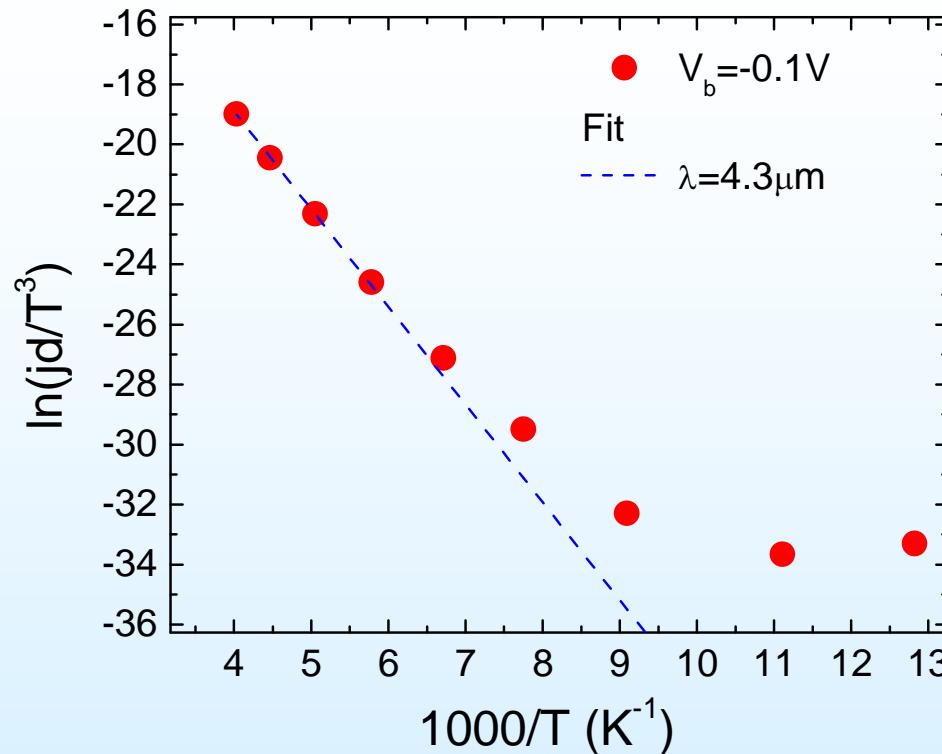


Dark current vs. perimeter/area ratio



- Shallow etched devices - etching just below the barrier
- The dark current density
 - $j_d = 5 \times 10^{-6} \text{ A}/\text{cm}^2$ at $V_b = -0.1 \text{ V}$ and $T = 150 \text{ K}$
 - $j_d = 2 \times 10^{-3} \text{ A}/\text{cm}^2$ at $T = 200 \text{ K}$
- The dark current vs. perimeter/area ratio is flat
 - No the surface leakage current
 - No the lateral current collection due to a partial pixel delineation
 - Indicative of a large ratio of pixel size to lateral diffusion length

Arrhenius analysis

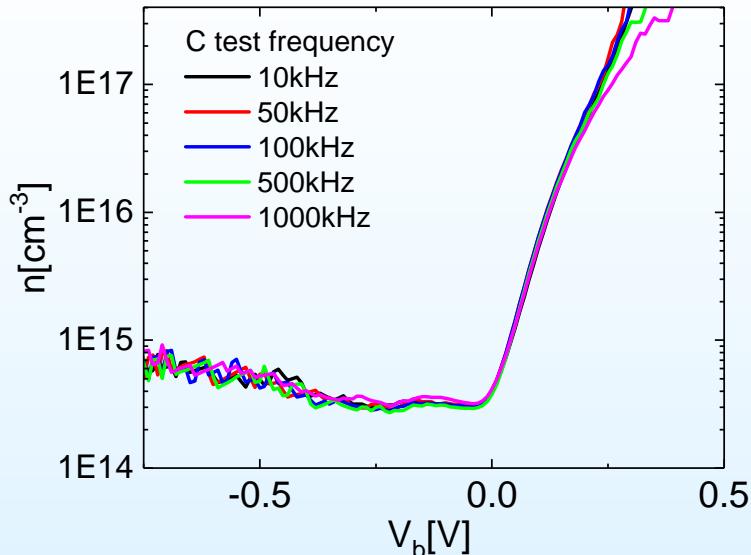
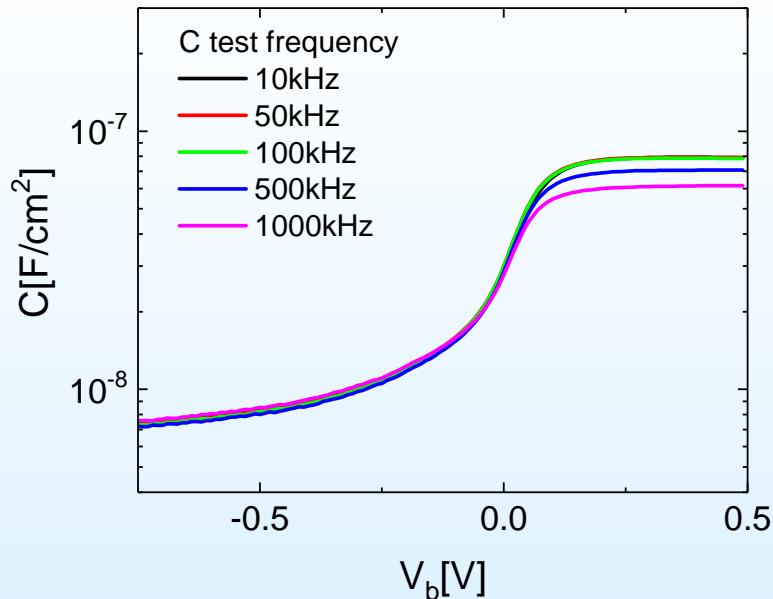


- Dark current fit (the dashed line): $j_d \sim T^3 \exp(-E_G/k_B T)$
 - $E_G^f = 4.3\mu\text{m}$ found from the fit to the data
 - Close to the superlattice bandgap $E_G = 4.2\mu\text{m}$
- Dark current is diffusion limited at low bias and temperatures above 150K
- The activation energy decrease at temperatures below 150K
 - Generation-recombination (g-r) and tunneling currents starts to dominate



Capacitance-Voltage measurements

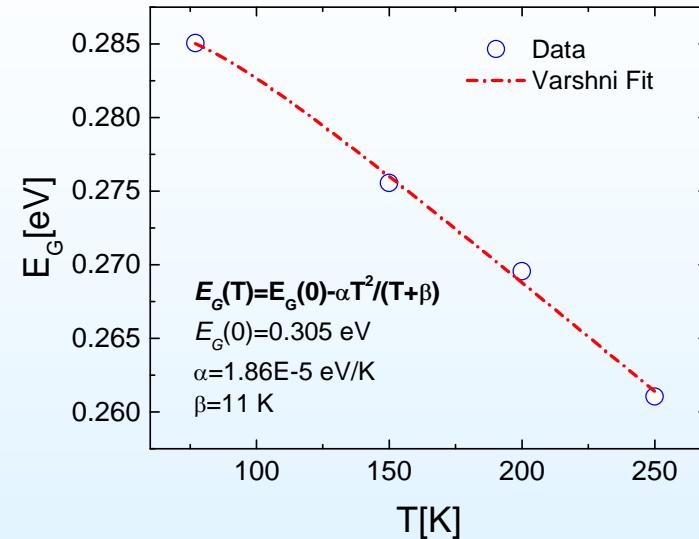
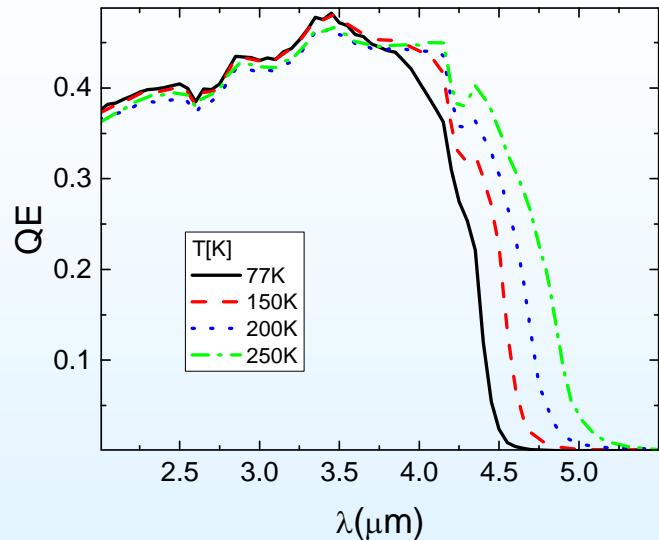
JPL
Jet Propulsion Laboratory
California Institute of Technology



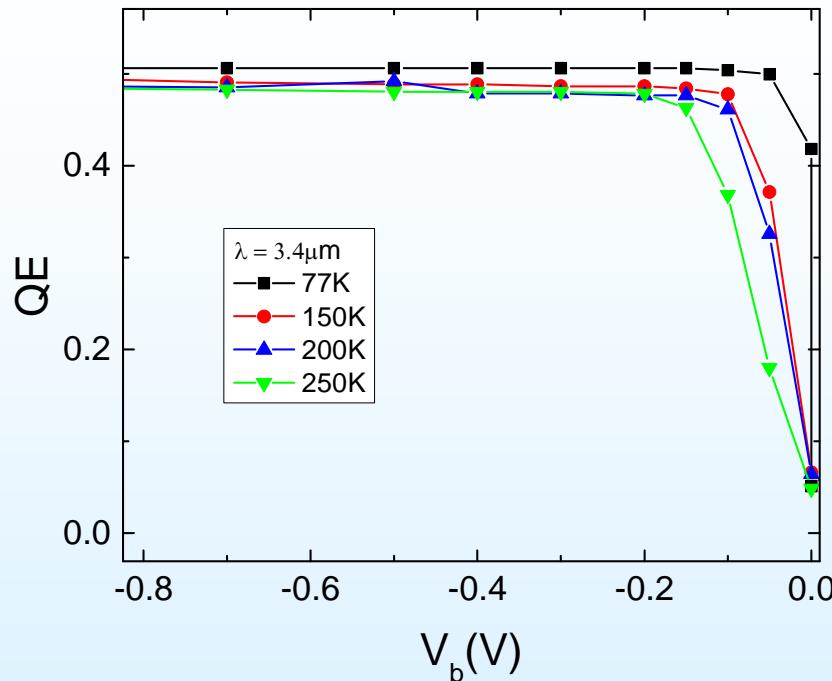
- Capacitance vs. voltage (C-V) was measured at $T=77\text{K}$
- Carrier concentration was calculated from C-V data using expression for diodes
 - $n_{\text{abs}} = 3\text{-}4 \times 10^{14} \text{ cm}^{-3}$

$$n = \frac{2}{q\epsilon_0\epsilon_s A^2 \frac{d}{dV} \left(\frac{1}{C^2} \right)} = \frac{2}{q\epsilon_0\epsilon_s \frac{d}{dV} \left(\frac{1}{(C/A)^2} \right)}$$

Spectral response

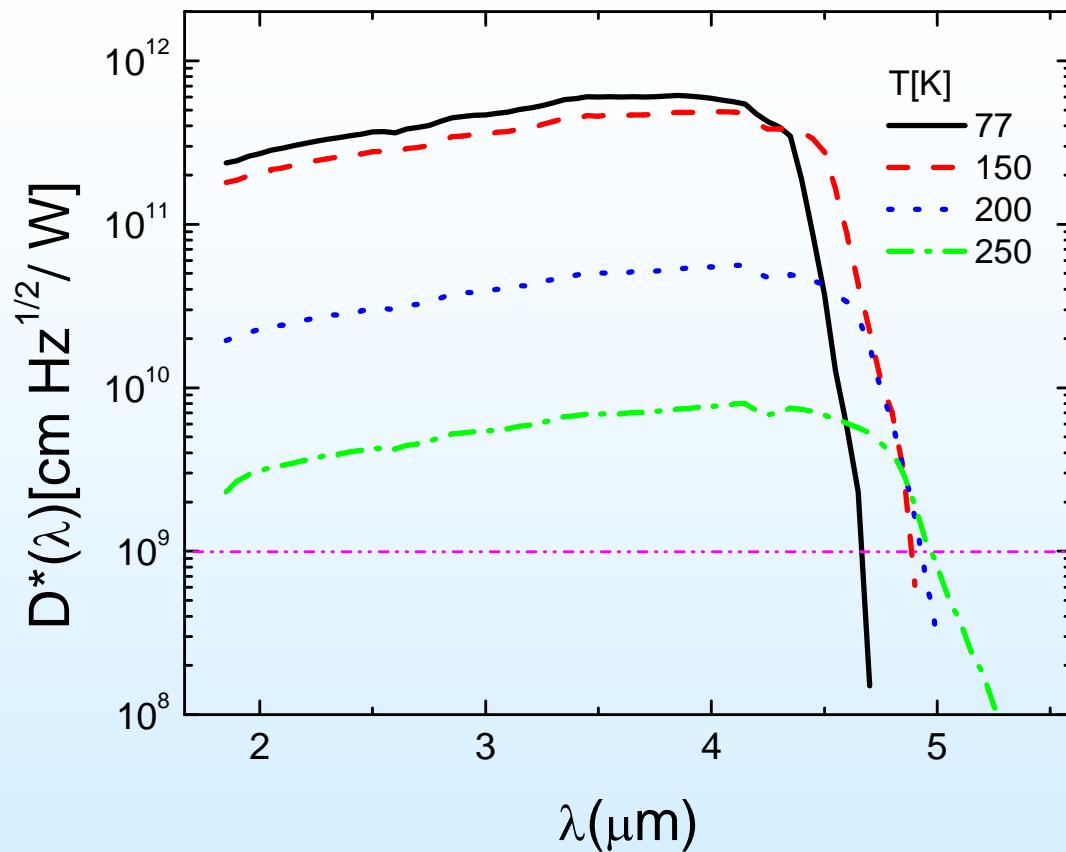


- Spectral response of backside-illuminated detectors without antireflection coating
 - The transmission of the GaSb substrate >95% for $\lambda < 6\mu\text{m}$
 - Double pass response
- The cut-off wavelengths, λ_c changes with temperature
 - $\lambda_c = 4.34 \mu\text{m}$ at $T = 77$ K
 - $\lambda_c = 4.77 \mu\text{m}$ at $T = 250$ K
- Fit bandgap change with temperature using Varshni expression



- The maximum Quantum Efficiency is $QE^{max} \approx 0.5$
 - Does not change with temperature in the temperature range $T = 77 - 250$ K.
- QE estimation from absorption: $QE_{est} = (1-R)(\alpha + \alpha(1-\alpha))$
 - α is a single-pass absorption and $R = 0.34$ is the reflectance of GaSb substrate
 - $QE_{est} \approx 0.6$ at $\lambda=3.4$ mm is very close to the measured $QE^m \approx 0.5$
- Turn-on bias, V_{on} , is less than 50 mV at $T = 77$ K
 - Indicates good valence band alignment between the barrier and absorber
 - Turn-on bias increases with temperature to about $V_{on} = 150$ mV at $T = 250$ K
 - Turn-on bias increase can be attributed to band-bending effects

Detectivity D^*



Thermal detector

- Detectivity, $D^*(\lambda)$ is for background T300K, $f/2$ field of view and 3 – 5 μm window
- Detectors are background limited at $T = 150\text{ K}$ and below
 - $D^*(\lambda) = 3 - 6 \times 10^{11} \text{ cm Hz}^{0.5}/\text{W}$
- $D^*(\lambda) = 2 - 4 \times 10^{10} \text{ cm Hz}^{0.5}/\text{W}$ at $T = 200\text{ K}$



Summary

JPL
Jet Propulsion Laboratory
California Institute of Technology

We extended the cut-off wavelength λ_c of bulk InAsSb nBn detectors to $\lambda_c = 4.6 \mu\text{m}$ at $T = 200 \text{ K}$ by incorporating series of single InSb monolayer into InAsSb absorber

- Detectors with $2\mu\text{m}$ thick absorber showed a temperature independent quantum efficiency $QE^m \approx 0.5$ for back-side illumination without antireflection coating.
- The dark current density was $j_d = 5 \times 10^{-6} \text{ A/cm}^2$ at $T = 150\text{K}$, and increased to $j_d = 2 \times 10^{-3} \text{ A/cm}^2$ at $T = 200 \text{ K}$.
- At temperatures of $T = 150 \text{ K}$ and below, the demonstrated photodetectors operate in background limited performance (BLIP) mode, with detectivity $D^*(\lambda) = 3-6 \times 10^{11} \text{ cm Hz}^{0.5}/\text{W}$ for the background temperature of 300 K, and $f/2$ field of view.